

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re Patent Applica	ition of:		
Kun-ho CHO et al.			
Application No.: 10	/644,933	Group Art Unit:	
Filed: August 21, 2	003	Examiner:	
For: SCROLLING	For: SCROLLING PROJECTION SYSTEM AND METHOD		
	INFORMATION DISCLOS	SURE STATEMENT	
Commissioner for I PO Box 1450 Alexandria, VA 223 Sir:			
provided certain info subject U.S. patent if it is deemed mate	ormation which the Examiner managerial to the examination of the su	ovisions of 37 CFR § 1.56, there is hereby ay consider material to the examination of the the Examiner make this information of record bject application. mation Disclosure Statement are:	
 1a.			

indicates the degree of relevance found by the foreign office". (See MPEP 609, Minimum Requirements for an Information Disclosure Statement, Part A(3): Concise Explanation of Relevance, pp. 600-100 to 600-101, Rev. 1,

2b. 🔲

Feb. 2000.)

set forth in the application.

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3.	to be, m (other th	ission is made that the aterial to patentability r an search report(s) fro onal Search Report, if	nor a represer om a counterp	ntation that a search ha art foreign application	as been made or a PCT
				Respectfully submitted	d,
				STAAS & HALSEY LL	.Р
Dated:	10/13	5/03	By:	AT 1	$X \subset X$
	w York Ave	e., N.W., Suite 700	7	Stephen T. Boughner	
Washing	ton, D.C.	20005		Registration No. 45,3	17
	ne: (202) 4				
Facsimile	e: (202) 43	4-1501			



LIST OF COPENDING APPLICATIONS

		ATTACHMENT 1(f)
AT	TORNEY DOCKET NO.	APPLICATION NO.
	293.1958	10/644,933
FIF	RST NAMED INVENTOR	
	un-ho CHO, et al.	
FIL	ING DATE	GROUP ART UNIT
A	ugust 21, 2003	

The following, prior-filed, copending U.S. patent application(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application. Pursuant to 37 CFR 1.98(a)(2)(iii), a copy of the identified copending application(s) is provided.

It is requested that the Examiner acknowledge his consideration of application(s) below-listed by initialling same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT APPLICATION DOCUMENTS

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*EXAMINER INITIAL		U.S. SERIAL NO.	FILING DATE	NAME	ASSIGNEE
	1	10/644,883	August 21, 2003	Dae-sik KIM, et al.	Samsung Electronics Co., Ltd.
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EXAMINER	DATE CONSIDERED	
	B/ 112 001101B2112B	
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*EXAMINER: Initial if reference considered, whether or not cita		
citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		